



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto, et al.

Art Unit : 2823

Serial No. : 10/025,322

Examiner : Julio J. Maldonado

Filed : December 18, 2001

Confirmation No.: 2823

Title : LASER ANNEALING METHOD AND LASER ANNEALING DEVICE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO ELECTION OF SPECIES REQUIREMENT

Responsive to the action mailed June 24, 2003, applicants elect the invention of Species II, directed to a method of manufacturing a semiconductor film including preheating said semiconductor film to form an oxide film and applying a laser beam to said semiconductor film through said oxide film to form a crystalline semiconductor film in a nitrogen atmosphere. Claims 4-12 and 16-26 are readable on the species and claims 1-3 are generic. The election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 24, 2003


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